

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

SHOYA et al.

Application No. Unassigned

Art Unit: Unassigned

Filed: August 4, 2003

Examiner: Unassigned

For: SEMICONDUCTOR WAFER
PROCESSING APPARATUS

PRELIMINARY AMENDMENT

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Prior to the examination of the above-identified patent application, please enter the following amendments and consider the following remarks.